

Docket No.: 1592-0163PUS1
(Patent)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Masashi NAKAMURA et al.

Application No.: 10/589,733

Confirmation No.: 2225

Filed: March 22, 2007

Art Unit: 2895

For: VAPOR PHASE GROWTH METHOD

Examiner: A. K. Singal

AMENDMENT UNDER § 1.111

MS AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated April 15, 2010, the period for response having been extended one (1) month to August 15, 2010, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

Amendments to the Claims begin on page 2.

Remarks begin on page 3.